

08/03/01  
JC853 U.S. PTO

PATENT

Docket No. JCLA7354

Date: 8-3-2001

Page 1

JC978 U.S. PTO  
09/922253  
10/03/01

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231  
ATTENTION: APPLICATION BRANCH

Sir:

Transmitted herewith for filing is the patent application of

Inventors: Chih Yuan Huang, Chin Hsiang Lin

For: METHOD FOR FABRICATING N-TYPE DOPED POLYCRYSTALLINE SILICON

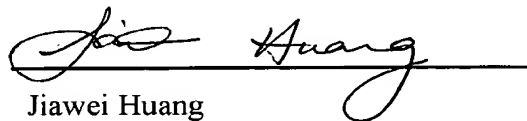
Enclosed are:

- ☒ Specification 10 pages.
- ☒ 2 Sheets of drawings
- ☒ Recordation Form Cover sheet with 2 pages assignment.
- ☐ A certified copy of Taiwan Patent Application No.      dated
- ☒ **SIGNED** declaration and power of attorney.
- ☒ Return Prepaid postcard.

CLAIMS AS FILED

FOR	NUMBER FILED	NUMBER EXTRA	RATE	FEE
Basic Fee			\$710.00	\$710.00
Total Claims	14	— 20 = 0 ×	\$18.00	\$0.00
Independent Claims	3	— 3 = 0 ×	\$80.00	\$0.00
If application contains any multiple dependent claim (s), then add			\$270.00	\$0.00
TOTAL FILING FEE				\$710.00

- ☒ A check in the amount of \$710.00 cover the filing fee is enclosed.
- ☒ A check in the amount of \$40.00 to cover the assignment recording fee.
- ☒ A duplicate copy of this sheet is enclosed.

  
Jiawei Huang

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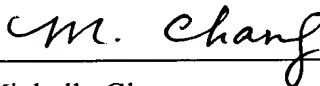
**CERTIFICATE OF MAILING BY "EXPRESS MAIL"**

**Docket No.** : JCLA7354  
**Applicant(s)** : Chih Yuan Huang, Chin Hsiang Lin  
**For** : METHOD FOR FABRICATING N-TYPE  
DOPED POLYCRYSTALLINE SILICON  
**"Express Mail"** : EL 800769121 US  
**Mailing Label No.**  
**Date of Deposit** : August 3, 2001

I hereby certify that the accompanying

Transmittal in Duplicate; Specification 10 pages, 2 sheets of drawings; **SIGNED**  
Declaration and Power of Attorney 2 pages; Recordation Form Cover Sheet and  
Assignment 3 pages; Checks for Filing Fee(s); Return Prepaid Postcard

are being deposited with the United States Postal Service "Express Mail Post Office to  
Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the  
Assistant Commissioner for Patents, Washington, D.C. 20231.

  
\_\_\_\_\_  
Michelle Chang